

universidade de aveiro CiCECO centro de investigação em materiais cerâmicos e compósitos				
Electron Energy Loss Spectrometry				
Electrons that are inelastically (forward) scattered in the TEM are used for chemical analysis of the specimen. Electron energy loss spectrometry (EELS)				
The inelastic scattering process can promote:				
1) The transition of an electron from an inner-shell (K,L,M) to an unoccupied energy level (i.e. above the Fermi level) or to the vacuum (ionization).				
2) Transition of a valence electron across the energy gap (insulators and semiconductors) or excitation of a plasmon resonance (collective oscillation of free electrons)				
The energy loss by the incident electrons is characteristic of the chemical properties of the specimen				
In EELS we are interested in measuring the "number of electrons" that have lost a given amount of energy> this traduces the relative probability that a particular transition occurs				
When a core electron is promoted to an unoccupied state, the density of these final states determines the relative probability of the transition				

















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Elemental Composition: EFTEM				
$\mathbb{E} = \mathbb{E} + $	3 images/element using:   3 images/element using:   Nd M <sub>45</sub> edge: @ 978 eV   Ti L <sub>23</sub> edge: @ 455 eV   Ba M <sub>45</sub> edge: @ 781 eV   Color overlays,RGB images:   - assign a color to each elemental map: Ti green, Nd blue and Ba red   - superimpose three color layers to form RGB composite   shows chemical phase distribution qualitatively only			
G. Kothleitner, Felmi, Graz, Austria	0 <u>0n</u> m			































![](_page_13_Figure_0.jpeg)

![](_page_13_Figure_1.jpeg)

![](_page_14_Figure_0.jpeg)

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El	DX - TEM	vs. SEM	
Simulation of the electron tra solid constituted of 100 nm th	jectories in o ick Ti film	Б	60 mm 28.6 mm
• 1000 electron trajectories an • Incident energy varies from (step 100 keV)	re displayed 100 to 300 k	eV	57.1 cm
EDX in the TEM: resolution just than the probe size! Resolution incident energy!	st slightly lov n increases w	ver ith 100 kV	1123 m
5	6.0 nm	5	0.0 mm
	28.6 nm		28.6 m
	57.5 nm		57.1 em
***2700 LV/	85.7 nm	Ti 100.00 nm	85.7 nm
	114.3 mm	300 kV	114.3 m
-80 0 mm -40 0 mm 40 0 mm 40 0 mm	80.0 nm	-80.0 nm -40.0 nm	0.0 nm 40.0 nm 80.0 nm

![](_page_15_Figure_0.jpeg)

![](_page_15_Figure_1.jpeg)